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**STATEMENT UNDER 37 C.F.R. 1.97(e) ACCOMPANYING  
INFORMATION DISCLOSURE STATEMENT**

Docket No.  
NEC WNZ-2212

In Re Application Of:  
TANABE et al.

**COPY**

Serial No.  
09/612,551f

Filing Date  
July 7, 2000

Examiner  
EVANS, GEOFFREY S.

Group Art Unit  
1725

Invention: Semiconductor Thin Film Forming System

RECEIVED  
NOV 21 2003  
TC 1700

TO THE ASSISTANT COMMISSIONER FOR PATENTS:

This is a statement under the provisions of 37 CFR 1.97(e) in the above-identified application.

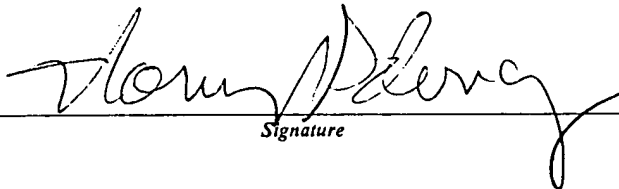
Check applicable statement herebelow:

Statement Under 37 CFR 1.97(e)(1)

- ☒ Each item of information contained in the accompanying Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement.

Statement Under 37 CFR 1.97(e)(2)

- ☐ No item of information contained in the accompanying Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the undersigned person, after making reasonable inquiry, no item of information contained in the accompanying Information Disclosure Statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the Information Disclosure Statement.

  
Signature


Dated:

June 19, 2003

Norman P. Soloway  
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